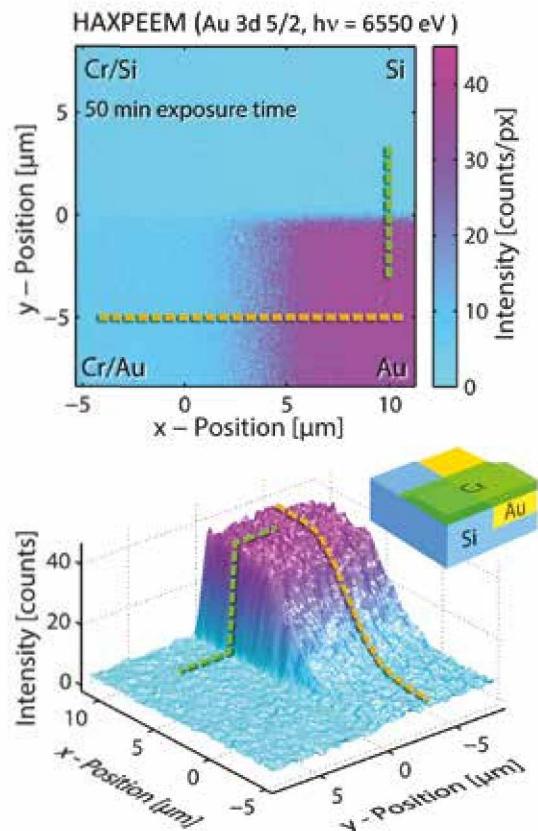


HAXPEEM

3D-HAXPES UP TO 10 keV

- Imaging HAXPES (3D-HAXPES)
- High Resolution Energy filtered PEEM
- Momentum Microscopy / μ -ARPES
- Small Area Spectroscopy
- Energy Range from 0 to 10 keV
- Aberration Compensated Imaging Double Sphere Filter (patented)
- Based on the NanoESCA III Design
- High Transmission
- True 2D Event Counting

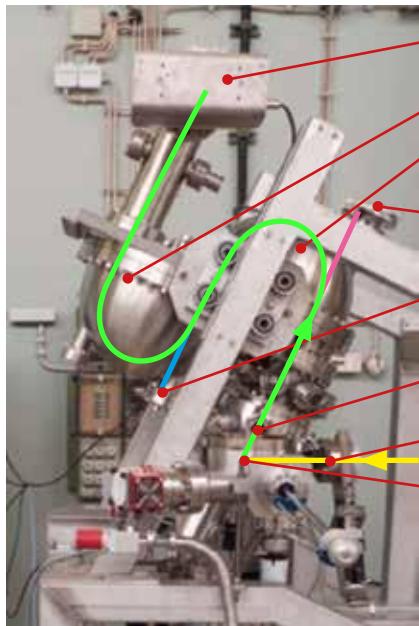


Ref.: M.Patt, C. Wiemann, N. Weber, M. Escher, A. Gloskovskii, W. Drube, M. Merkel, C. M. Schneider, Rev. Sci. Instrum., **85**, 1137 (2014)



Brochure

HAXPEEM: Essentials



imaging detector (energy filtered)

2nd hemisphere1st hemisphere

imaging detector (PEEM image)

channeltron detector

path of photo electrons

synchrotron light

sample position

Field of view(FoV)

Real space 6 ... 800 µm

k-space > ± 3.0 Å⁻¹

Lateral resolution

NanoESCA III mode < 40 nm (20 nm achieved)

HAXPEEM @ 6.5 keV < 500 nm (410 nm achieved)

k-space resolution 0.05 Å⁻¹ (0.008 Å⁻¹ achieved)

Kinetic energy range

NanoESCA III mode 0 200 eV (0 ... 1600 eV opt.)

HAXPEEM mode 0... 10 keV

Energy resolution

NanoESCA III < 25 meV @ 0 ... 200 eV

< 50 meV @ 0 ... 1.6 keV

HAXPEEM < 100 meV @ 0 ... 10 keV

1st dedicated HAXPEEM up to 10 keV
operated @ PETRA III, Hamburg

Manually driven iris field aperture FoV range 0...200 µm

Piezo driven contrast aperture (CA) 5 aperture sizes, x/y adjustable

Position read out for IS stage and CA accuracy 10 µm

2D event counting for single electron detection 2x10⁵ counts/sec max. count rate

Integrated x/y sample stage (IS stage) piezo driven, x/y: ±4 mm (option)

LHe cooled sample stage On request

